L Number	Hits	Search Text	DB	Time stamp
-	180	156/345.24.ccls.	USPAT; US-PGPUB	2003/08/05 17:00
-	16	156/345.24.ccls. and (lift$3 with pin)	USPAT; US-PGPUB	2003/07/30 17:28
-	9	(h011021/$.ipc. or c23c016/$.ipc.) and ((detect near7 (wafer or substrate)) and lift$4 and pin)	JPO; DERWENT	2003/07/30 17:44
-	15	(h011021/$.ipc. or c23c016/$.ipc.) and (((detector or sens$3) near7 (wafer or substrate)) and lift$4 and pin)	JPO; DERWENT	2003/07/30 17:44
-	29	(h011021/$.ipc. or c23c016/$.ipc.) and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)	JPO; DERWENT	2003/07/30 18:52
-	20	((h011021/$.ipc. or c23c016/$.ipc.) and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)) not ((h011021/$.ipc. or c23c016/$.ipc.) and ((detect near7 (wafer or substrate)) and lift$4 and pin))	JPO; DERWENT	2003/07/30 17:45
-	83	(h011021/$.ipc. or c23c016/$.ipc.) and (((detect$4 or sens$3) near7 (wafer or substrate)) and capacitive)	JPO; DERWENT	2003/07/30 18:50
-	180	(h011021/$.ipc. or c23c016/$.ipc.) and (((detect$4 or sens$3) near7 (wafer or substrate)) and (capacitive nera proximity))	JPO; DERWENT	2003/07/30 18:50
-	2	(h011021/$.ipc. or c23c016/$.ipc.) and (((detect$4 or sens$3) near7 (wafer or substrate)) and (capacitive near proximity))	JPO; DERWENT	2003/07/30 18:51
-	0	(118/715-733).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)	JPO; DERWENT	2003/07/30 18:53
-	244	(118/715-733).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)	USPAT; US-PGPUB	2003/07/30 18:54
-	40	(118/500).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)	USPAT; US-PGPUB	2003/07/30 18:54
-	136	(156/345.$2).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)	USPAT; US-PGPUB	2003/07/30 18:54
-	310	((118/715-733).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)) or ((118/500).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)) or ((156/345.$2).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin))	USPAT; US-PGPUB	2003/07/30 18:55
-	25	(((118/715-733).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)) or ((118/500).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin)) or ((156/345.$2).ccls. and (((detect$4 or sens$3) near7 (wafer or substrate)) and lift$4 and pin))) and (capacitive near proximity)	USPAT; US-PGPUB	2003/07/30 18:55
-	1	6403933.pn.	USPAT; US-PGPUB	2003/08/05 16:38
-	1	6150638.pn.	USPAT; US-PGPUB	2003/08/05 17:00
-	1	6592673.pn.	USPAT; US-PGPUB	2003/08/05 18:41